

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of	)	
	)	
Yong-jo PARK et al.	)	Group Art Unit: Unassigned
	)	
Application No.: Unassigned	)	Examiner: Unassigned
Divisional of Application No. 10/055,999	)	
	)	Confirmation No.: Unassigned
Filed: April 5, 2004	)	
	)	
For: GaN SERIES SURFACE-EMITTING	)	
LASER DIODE HAVING SPACER	)	
FOR EFFECTIVE DIFFUSION OF	)	
HOLES BETWEEN P-TYPE	)	
ELECTRODE AND ACTIVE LAYER,	)	
AND METHOD FOR	)	
MANUFACTURING THE SAME	)	

**PELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination on the merits, kindly amend the above-captioned application as follows: